

Irish Standard I.S. EN 61000-4-20:2010

Electromagnetic compatibility (EMC) --Part 4-20: Testing and measurement techniques - Emission and immunity testing in transverse electromagnetic (TEM) waveguides (IEC 61000-4 -20:2010 (EQV))

© NSAI 2010 No copying without NSAI permission except as permitted by copyright law.

Incorporating amendments/corrigenda issued since publication:	

The National Standards Authority of Ireland (NSAI) produces the following categories of formal documents:

Irish Standard - national specification based on the consensus of an expert panel and I.S. xxx: subject to public consultation.

Standard Recommendation - recommendation based on the consensus of an expert panel and subject to public consultation.

SWiFT xxx: A rapidly developed recommendatory document based on the consensus of the participants of an NSAI workshop.

This document replaces: EN 61000-4-20:2003

This document is based on: EN 61000-4-20:2010 EN 61000-4-20:2003

Published: 5 November, 2010 28 April, 2003

This document was published

under the authority of the NSAI and comes into effect on:

ICS number: 33.100.10 33.100.20

22 November, 2010

NSAI

T +353 1 807 3800

Sales:

1 Swift Square, Northwood, Santry Dublin 9

F +353 1 807 3838 E standards@nsai.ie T +353 1 857 6730 F +353 1 857 6729 W standards.ie

W NSALie

Údarás um Chaighdeáin Náisiúnta na hÉireann

EUROPEAN STANDARD

EN 61000-4-20

NORME EUROPÉENNE EUROPÄISCHE NORM

November 2010

ICS 33.100.10; 33.100.20

Supersedes EN 61000-4-20:2003 + A1:2007

English version

Electromagnetic compatibility (EMC) Part 4-20: Testing and measurement techniques Emission and immunity testing in transverse electromagnetic (TEM) waveguides

(IEC 61000-4-20:2010)

Compatibilité électromagnétique (CEM) -Partie 4-20: Techniques d'essai et de mesure -Essais d'émission et d'immunité dans les guides d'onde TEM (CEI 61000-4-20:2010)

Elektromagnetische Verträglichkeit (EMV) -Teil 4-20: Prüf- und Messverfahren -Messung der Störaussendung und Störfestigkeit in transversalelektromagnetischen (TEM-)Wellenleitern (IEC 61000-4-20:2010)

This European Standard was approved by CENELEC on 2010-10-01. CENELEC members are bound to comply with the CEN/CENELEC Internal Regulations which stipulate the conditions for giving this European Standard the status of a national standard without any alteration.

Up-to-date lists and bibliographical references concerning such national standards may be obtained on application to the Central Secretariat or to any CENELEC member.

This European Standard exists in three official versions (English, French, German). A version in any other language made by translation under the responsibility of a CENELEC member into its own language and notified to the Central Secretariat has the same status as the official versions.

CENELEC members are the national electrotechnical committees of Austria, Belgium, Bulgaria, Croatia, Cyprus, the Czech Republic, Denmark, Estonia, Finland, France, Germany, Greece, Hungary, Iceland, Ireland, Italy, Latvia, Lithuania, Luxembourg, Malta, the Netherlands, Norway, Poland, Portugal, Romania, Slovakia, Slovenia, Spain, Sweden, Switzerland and the United Kingdom.

CENELEC

European Committee for Electrotechnical Standardization Comité Européen de Normalisation Electrotechnique Europäisches Komitee für Elektrotechnische Normung

Management Centre: Avenue Marnix 17, B - 1000 Brussels

© 2010 CENELEC - All rights of exploitation in any form and by any means reserved worldwide for CENELEC members.

- 2 -

Foreword

The text of document 77B/637/FDIS, future edition 2 of IEC 61000-4-20, prepared by SC 77B, High frequency phenomena, of IEC TC 77, Electromagnetic compatibility, was submitted to the IEC-CENELEC parallel vote and was approved by CENELEC as EN 61000-4-20 on 2010-10-01.

This European Standard supersedes EN 61000-4-20:2003 + A1:2007.

The main changes with respect to EN 61000-4-20:2003 + A1:2007 are the following:

- consistency of terms (e.g. test, measurement, etc.) has been improved;
- clauses covering test considerations, evaluations and the test report have been added;
- references to large TEM waveguides have been eliminated;
- a new informative annex has been added to deal with calibration of E-field probes.

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. CEN and CENELEC shall not be held responsible for identifying any or all such patent rights.

The following dates were fixed:

 latest date by which the EN has to be implemented at national level by publication of an identical national standard or by endorsement

(dop) 2011-07-01

 latest date by which the national standards conflicting with the EN have to be withdrawn

(dow) 2013-10-01

Annex ZA has been added by CENELEC.

Endorsement notice

The text of the International Standard IEC 61000-4-20:2010 was approved by CENELEC as a European Standard without any modification.

In the official version, for Bibliography, the following notes have to be added for the standards indicated:

CISPR 20	NOTE	Harmonized as EN 55020.
CISPR 25	NOTE	Harmonized as EN 55025.
IEC 60068-1	NOTE	Harmonized as EN 60068-1.
IEC 60118-13	NOTE	Harmonized as EN 60118-13.
IEC 61967-2	NOTE	Harmonized as EN 61967-2.
IEC 62132-2	NOTE	Harmonized as EN 62132-2.
[11] CISPR 14 series	NOTE	Harmonized in EN 55014 series (not modified).
[23] IEC 61000-2-9	NOTE	Harmonized as EN 61000-2-9.
[42] IEC 61000-4-3	NOTE	Harmonized as EN 61000-4-3.
[44] CISPR 16-4-2	NOTE	Harmonized as EN 55016-4-2.

Annex ZA (normative)

Normative references to international publications with their corresponding European publications

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

NOTE When an international publication has been modified by common modifications, indicated by (mod), the relevant EN/HD applies.

<u>Publication</u>	<u>Year</u>	<u>Title</u>	EN/HD	<u>Year</u>
IEC 60050-161	-	International Electrotechnical Vocabulary (IEV) - Chapter 161: Electromagnetic compatibility	-	-
IEC 61000-2-11	1999	Electromagnetic compatibility (EMC) - Part 2-11: Environment - Classification of HEMP environments	-	-
IEC 61000-4-23	-	Electromagnetic compatibility (EMC) - Part 4-23: Testing and measurement techniques - Test methods for protective devices for HEMP and other radiated disturbances	EN 61000-4-23	-
IEC/TR 61000-4-32	-	Electromagnetic compatibility (EMC) - Part 4-32: Testing and measurement techniques - High-altitude electromagnetic pulse (HEMP) simulator compendium	-	-
IEC/TR 61000-5-3	-	Electromagnetic compatibility (EMC) - Part 5: Installation and mitigation guidelines - Section 3: HEMP protection concepts	-	-
CISPR 16-1-1	-	Specification for radio disturbance and immunity measuring apparatus and methods Part 1-1: Radio disturbance and immunity measuring apparatus - Measuring apparatus	EN 55016-1-1 -	-
CISPR 16-1-4	-	Specification for radio disturbance and immunity measuring apparatus and methods Part 1-4: Radio disturbance and immunity measuring apparatus - Antennas and test sites for radiated disturbance measurements	EN 55016-1-4 -	-
CISPR 16-2-3	2006	Specification for radio disturbance and immunity measuring apparatus and methods Part 2-3: Methods of measurement of disturbances and immunity - Radiated disturbance measurements	EN 55016-2-3 ¹⁾ -	2006
CISPR 22 (mod)	-	Information technology equipment - Radio disturbance characteristics - Limits and methods of measurement	EN 55022	-

 $^{^{1)}}$ EN 55016-2-3 is superseded by EN 55016-2-3:2010, which is based on CISPR 16-2-3:2010.

_

This is a free page sample. Access the full version online.

I.S. EN 61000-4-20:2010

This page is intentionally left BLANK.

- 2 -

61000-4-20 © IEC:2010

CONTENTS

FOI	REWO	DRD	4
INT	RODI	JCTION	6
1	Scop	e and object	7
2	Norm	native references	7
3	Term	s, definitions and abbreviations	8
	3.1	Terms and definitions	8
	3.2	Abbreviations	11
4	Gene	eral	11
5	TEM	waveguide requirements	12
	5.1	General	12
	5.2	General requirements for the use of TEM waveguides	
		5.2.1 TEM mode verification	
		5.2.2 Test volume and maximum EUT size	
	- 0	5.2.3 Validation of usable test volume	13
	5.3	Special requirements and recommendations for certain types of TEM waveguides	15
		5.3.1 Set-up of open TEM waveguides	
		5.3.2 Alternative TEM mode verification for a two-port TEM waveguide	
6	Over	view of EUT types	16
	6.1	General	16
	6.2	Small EUT	16
	6.3	Large EUT	16
7	Labo	ratory test conditions	17
	7.1	General	
	7.2	Climatic conditions	
^	7.3	Electromagnetic conditions	
8		uation and reporting of test results	
		(normative) Emission testing in TEM waveguides	
		(normative) Immunity testing in TEM waveguides	
		(normative) HEMP transient testing in TEM waveguides	
		(informative) TEM waveguide characterization	
		(informative) Calibration method for E-field probes in TEM waveguides	
Bib	liogra	phy	71
		1 – Routing the exit cable to the corner at the ortho-angle and the lower edge it volume	30
Fig	ure A.	2 – Basic ortho-axis positioner or manipulator	31
Fig	ure A.	3 – Three orthogonal axis-rotation positions for emission measurements	32
Fig	ure A.	4 – Twelve-face (surface) and axis orientations for a typical EUT	33
Fig	ure A.	5 – Open-area test site (OATS) geometry	34
Fig	ure A.	6 – Two-port TEM cell (symmetric septum)	35
Fig	ure A.	7 – One-port TEM cell (asymmetric septum)	36
Fig	ure A.	8 – Stripline (two plates)	38
Fig	ure A.	9 – Stripline (four plates, balanced feeding)	39

61000-4-20 © IEC:2010

- 3 -

Figure B.1 – Example of test set-up for single-polarization TEM waveguides	44
Figure B.2 – Uniform area calibration points in TEM waveguide	45
Figure C.1 – Frequency domain spectral magnitude between 100 kHz and 300 MHz	52
Figure D.1 – Simple waveguide (no TEM mode)	59
Figure D.2 – Example waveguides for TEM-mode propagation	59
Figure D.3 – Polarization vector	59
Figure D.4 – Transmission line model for TEM propagation	59
Figure D.5 – One- and two-port TEM waveguides	60
Figure E.1 – An example of the measurement points for the validation	62
Figure E.2 – Setup for validation of perturbation	63
Figure E.3 – Setup for measuring net power to a transmitting device	66
Figure E.4 – Example of setup for calibration of E-field probe	67
Figure E.5 – Setup for calibration of E-field probe by another method	69
Figure E.6 – Equivalent circuit of antenna and measurement apparatus	70
Table 1 – Values <i>K</i> for expanded uncertainty with normal distribution	15
Table B.1 – Uniform area calibration points	42
Table B.2 – Test levels	42
Table C.1 – Radiated immunity test levels defined in the present standard	52
Table E.1 – Calibration frequencies	63
Table E.2 – Calibration field strength level	64

– 4 –

61000-4-20 © IEC:2010

INTERNATIONAL ELECTROTECHNICAL COMMISSION

ELECTROMAGNETIC COMPATIBILITY (EMC) -

Part 4-20: Testing and measurement techniques – Emission and immunity testing in transverse electromagnetic (TEM) waveguides

FOREWORD

- 1) The International Electrotechnical Commission (IEC) is a worldwide organization for standardization comprising all national electrotechnical committees (IEC National Committees). The object of IEC is to promote international co-operation on all questions concerning standardization in the electrical and electronic fields. To this end and in addition to other activities, IEC publishes International Standards, Technical Specifications, Technical Reports, Publicly Available Specifications (PAS) and Guides (hereafter referred to as "IEC Publication(s)"). Their preparation is entrusted to technical committees; any IEC National Committee interested in the subject dealt with may participate in this preparatory work. International, governmental and non-governmental organizations liaising with the IEC also participate in this preparation. IEC collaborates closely with the International Organization for Standardization (ISO) in accordance with conditions determined by agreement between the two organizations.
- 2) The formal decisions or agreements of IEC on technical matters express, as nearly as possible, an international consensus of opinion on the relevant subjects since each technical committee has representation from all interested IEC National Committees.
- 3) IEC Publications have the form of recommendations for international use and are accepted by IEC National Committees in that sense. While all reasonable efforts are made to ensure that the technical content of IEC Publications is accurate, IEC cannot be held responsible for the way in which they are used or for any misinterpretation by any end user.
- 4) In order to promote international uniformity, IEC National Committees undertake to apply IEC Publications transparently to the maximum extent possible in their national and regional publications. Any divergence between any IEC Publication and the corresponding national or regional publication shall be clearly indicated in the latter.
- 5) IEC itself does not provide any attestation of conformity. Independent certification bodies provide conformity assessment services and, in some areas, access to IEC marks of conformity. IEC is not responsible for any services carried out by independent certification bodies.
- 6) All users should ensure that they have the latest edition of this publication.
- 7) No liability shall attach to IEC or its directors, employees, servants or agents including individual experts and members of its technical committees and IEC National Committees for any personal injury, property damage or other damage of any nature whatsoever, whether direct or indirect, or for costs (including legal fees) and expenses arising out of the publication, use of, or reliance upon, this IEC Publication or any other IEC Publications.
- 8) Attention is drawn to the Normative references cited in this publication. Use of the referenced publications is indispensable for the correct application of this publication.
- 9) Attention is drawn to the possibility that some of the elements of this IEC Publication may be the subject of patent rights. IEC shall not be held responsible for identifying any or all such patent rights.

International Standard IEC 61000-4-20 has been prepared by 77B: High-frequency phenomena, of IEC technical committee 77: Electromagnetic compatibility, in cooperation with CISPR (International Special Committee on Radio Interference) subcommittee A: Radio interference measurements and statistical methods.

This second edition cancels and replaces the first edition published in 2003 and its amendment 1 (2006), and constitutes a technical revision.

It forms Part 4-20 of IEC 61000. It has the status of a basic EMC publication in accordance with IEC Guide 107.

The main changes with respect to the first edition of this standard and its amendment are the following:

consistency of terms (e.g. test, measurement, etc.) has been improved;

61000-4-20 © IEC:2010

- 5 -

- clauses covering test considerations, evaluations and the test report have been added;
- references to large TEM waveguides have been eliminated;
- a new informative annex has been added to deal with calibration of E-field probes.

The text of this standard is based on the following documents:

FDIS	Report on voting
77B/637/FDIS	77B/641/RVD

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all parts of the IEC 61000 series, published under the general title *Electromagnetic compatibility (EMC)*, can be found on the IEC website.

The committee has decided that the contents of the base publication and its amendments will remain unchanged until the stability result date indicated on the IEC web site under "http://webstore.iec.ch" in the data related to the specific publication. At this date, the publication will be

- · reconfirmed.
- withdrawn,
- · replaced by a revised edition, or
- amended.

- 6 **-**

61000-4-20 © IEC:2010

INTRODUCTION

IEC 61000 is published in separate parts according to the following structure:

Part 1: General

General considerations (introduction, fundamental principles)

Definitions, terminology

Part 2: Environment

Description of the environment

Classification of the environment

Compatibility levels

Part 3: Limits

Emission limits

Immunity limits (in so far as they do not fall under the responsibility of the product committees)

Part 4: Testing and measurement techniques

Measurement techniques

Testing techniques

Part 5: Installation and mitigation guidelines

Installation guidelines

Mitigation methods and devices

Part 6: Generic Standards

Part 9: Miscellaneous

Each part is further subdivided into several parts, published either as International Standards, Technical Specifications or Technical Reports, some of which have already been published as sections. Others are and will be published with the part number followed by a dash and a second number identifying the subdivision (example: IEC 61000-6-1).

This part of IEC 61000 is an International Standard which gives emission, immunity and HEMP transient testing requirements.

61000-4-20 © IEC:2010

-7-

ELECTROMAGNETIC COMPATIBILITY (EMC) -

Part 4-20: Testing and measurement techniques – Emission and immunity testing in transverse electromagnetic (TEM) waveguides

1 Scope and object

This part of IEC 61000 relates to emission and immunity test methods for electrical and electronic equipment using various types of transverse electromagnetic (TEM) waveguides. These types include open structures (for example, striplines and electromagnetic pulse simulators) and closed structures (for example, TEM cells). These structures can be further classified as one-, two-, or multi-port TEM waveguides. The frequency range depends on the specific testing requirements and the specific TEM waveguide type.

The object of this standard is to describe

- TEM waveguide characteristics, including typical frequency ranges and EUT-size limitations;
- TEM waveguide validation methods for EMC tests;
- the EUT (i.e. EUT cabinet and cabling) definition;
- test set-ups, procedures, and requirements for radiated emission testing in TEM waveguides and
- test set-ups, procedures, and requirements for radiated immunity testing in TEM waveguides.

NOTE Test methods are defined in this standard for measuring the effects of electromagnetic radiation on equipment and the electromagnetic emissions from equipment concerned. The simulation and measurement of electromagnetic radiation is not adequately exact for quantitative determination of effects for all end-use installations. The test methods defined are structured for a primary objective of establishing adequate repeatability of results at various test facilities for qualitative analysis of effects.

This standard does not intend to specify the tests to be applied to any particular apparatus or system(s). The main intention of this standard is to provide a general basic reference for all interested product committees of the IEC. For radiated emissions testing, product committees should select emission limits and test methods in consultation with CISPR standards. For radiated immunity testing, product committees remain responsible for the appropriate choice of immunity tests and immunity test limits to be applied to equipment within their scope. This standard describes test methods that are separate from those of IEC 61000-4-3.1

2 Normative references

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 60050(161), International Electrotechnical Vocabulary – Chapter 161: Electromagnetic compatibility

IEC 61000-2-11:1999, Electromagnetic compatibility (EMC) – Part 2-11: Environment – Classification of HEMP environments

These other distinct test methods may be used when so specified by product committees, in consultation with CISPR and TC 77.



Product Page

- Dooking for additional Standards? Visit Intertek Inform Infostore
- Dearn about LexConnect, All Jurisdictions, Standards referenced in Australian legislation